

In re Application of:
Wada, et al.

Serial No.: 09/830,611

Confirmation No.:

Filed: April 30, 2001

**For: Film Deposition Method
 and Apparatus**

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1762

Examiner: Unknown

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37 CFR 1.8

I hereby certify that this correspondence is being deposited on 22 May, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

22 May 02 Date C. E. B. Patten Signature

The Assignee of the above captioned application, Applied Materials, Inc., hereby
revokes the previously appointed power of attorney for this application.

Assignee hereby appoints the following attorneys/agents to prosecute this application and transact all business in the Patent & Trademark Office connected therewith:

Raymond R. Moser, Jr.
B. Todd Patterson
Keith M. Tackett
William B. Patterson

Registration. No. 34,682
Registration No. 37,906
Registration No. 32,008
Registration No. 34,102

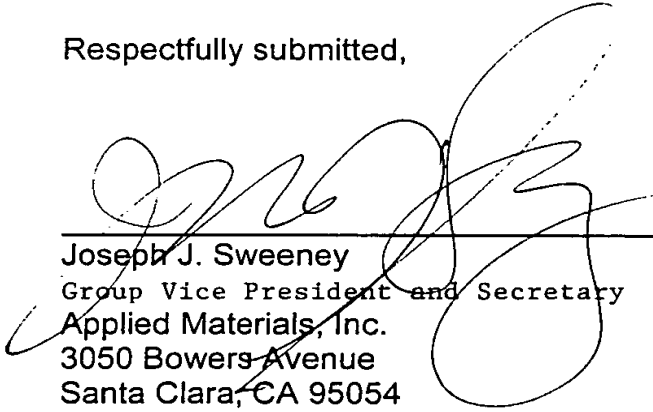
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Send correspondence and telephone calls to: /

William B. Patterson
MOSER, PATTERSON & SHERIDAN, LLP
3040 Post Oak Blvd., Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Fax (713) 623-4846

and grant full powers to prosecute this application, to make alterations and amendments therein, to inspect and make copies thereof and of any papers in appellate and inter party proceedings in which it may be involved, and to transact all business in the United States Patent & Trademark Office connected therewith.

Respectfully submitted,



Joseph J. Sweeney
Group Vice President and Secretary
Applied Materials, Inc.
3050 Bowers Avenue
Santa Clara, CA 95054

Date: May 1, 2002